



PATENT
Attorney Docket No. 0553-0299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
)
Takashi Hamada et al.)
)
Serial No: 10/051,064)
)
Filed: January 18, 2002)
)
Art Unit: 2823)
)
Examiner: F. Toledo)
)
For: SEMICONDUCTOR DEVICE)
AND METHOD OF)
MANUFACTURING THE SAME)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450,
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Signature

[Handwritten Signature]

Date September 16, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Dear Sir:

In response to the Office Action dated May 20, 2003, please amend the above-identified application as follows.

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